TRANSMITTAL FORM  (to be used for all correspondence after initial Total Number of Pages in This Submission	Filing Date  First Named Inventor  Art Unit  Examiner Name	Approved for use through 07/31/2006. OMB 0651-0031 latent and Trademark Office; U.S. DEPARTMENT OF COMMERCE ection of information unless it displays a valid OMB control number. 10/824,678  04/15/2004  RUECKES et al. 2812  TBA  112020.152 US2 NAN-28
	ENCLOSURES (Check all	AL-A
Fee Transmittal Form Fee Attached  Amendment/Reply After Final Affidavits/declaration(s)  Extension of Time Request Express Abandonment Request Information Disclosure Statement  Certified Copy of Priority Document(s) Reply to Missing Parts/ Incomplete Application Reply to Missing Parts under 37 CFR 1.52 or 1.53	Drawing(s)  Licensing-related Papers  Petition Petition to Convert to a Provisional Application Power of Attorney, Revocation Change of Correspondence A Terminal Disclaimer Request for Refund CD, Number of CD(s) Landscape Table on CD Remarks 1. Form PTO-1449 (5 pgs 2. 35 Publications	After Allowance Communication to TC  Appeal Communication to Board of Appeals and Interferences  Appeal Communication to TC (Appeal Notice, Brief, Reply Brief)  Proprietary Information  Status Letter Other Enclosure(s) (please Identify below):  - Postcard
SIGNA	I TURE OF APPLICANT, ATTOI	RNEY, OR AGENT
Firm Name Wilmer Cutler Picke	ering Hale and Dorr LLP	
Signature	Pet uns	
Printed name	Peter M. Dichiara	
Date 03	3/30/2005 F	Reg. No. 38,005
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Tina M. Douga

Typed or printed name

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03/30/2005





## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

RUECKES et al.

Serial No.:

10/824,678

Examiner:

TBA

Filed:

April 15, 2004

Group Art Unit: 2812

For:

**Process For Making Bit Erasable Devices Having Elements** 

**Made With Nanotubes** 

Atty. Docket No.:

112020.152 US2 NAN-28

## **CERTIFICATE OF MAILING UNDER 37 CFR 1.8(a)**

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## INFORMATION DISCLOSURE STATEMENT

Sir:

Applicants and their legal representatives hereby make of record on the attached Form PTO-1449 the following publications which are known to them and considered warranting disclosure under 37 C.F.R. §1.56 and 1.97-98.

Copies of the publications listed on the attached Form PTO-1449, with the exception of U.S. patents and U.S. patent publications, are submitted herewith. It is respectfully requested that the Examiner initial and return a copy of the subject Form PTO-1449 with the next Patent Office communication.

Serial No. 10/824,678 RUECKES et al.

Page 2

The submission of these publications does not constitute a representation by the Applicants that a search has been made or that no better art exists and does not constitute an admission that the listed publications are material or constitute "prior art." Applicants reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed publications, should one or more of the publications be applied against the claims of the present application.

As the Information Disclosure Statement is being filed prior to the mailing date of the first Office Action on the merits, no fee is believed to be due. However, in the event a fee is due, please charge any fee deficiency or credit any overpayment to Deposit Account No. <u>08-0219</u>.

Respectfully submitted,

Dated: March 30, 2005

Peter M. Dichiara Registration No. 38,005 Attorney for Applicants

Wilmer Cutler Pickering Hale and Dorr LLP 60 State Street Boston, Massachusetts 02109

Tel: (617) 526-6466 Fax: (617) 526-5000

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	Complete if Known	
Application Number	10/824,678	
Filing Date	April 15, 2004	
First Named Inventor	RUECKES et al.	
Art Unit	2812	
Examiner Name	TBA	
Attorney Docket Number	112010 152US2 NAN-28	

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Examiner Initials*	Cite No.1	Document Number  Number-Kind Code <sup>2(If known)</sup>	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
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	_			Application Number	10/824,678		
INFORMATION DISCLOSURE				Filing Date	April 15, 2004		
	STATEMEN'	T BY	APPLICANT	First Named Inventor	RUECKES et al.		
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				Examiner Name	TBA		
Sheet	2	of	5	Attorney Docket Number	112010.152US2 NAN-28		

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Sheet	3	of	5	Attorney Docket Number	112010.152US2 NAN-28	

		FOR	EIGN PATENT DOC	CUMENTS	
Examiner	Cite	Document Number	Publication Date	Name of Patentee or Applicant	Pages, Columns, Lines,
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			ISCLOSURE	Filing Date	April 15, 2004	
STATEMENT BY APPLICANT			APPLICANT	First Named Inventor	RUECKES et al.	
(Use as many sheets as necessary)				Art Unit	2812	
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